

AF/IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Sean C. Erickson
Serial No. : 10/627,289
Examiner : Hoa B. Trinh
Art Unit : 2814
Filed : July 25, 2003
For : LOW GATE RESISTANCE LAYOUT PROCEDURE
FOR RF TRANSISTOR DEVICES

Mail Stop AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

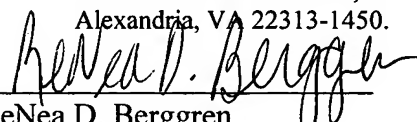
RESPONSE TO THE FINAL OFFICE ACTION DATED DECEMBER 28, 2004

CERTIFICATE OF MAILING/TRANSMISSION (37 C.F.R. § 1.8)

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ReNea D. Berggren

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☐ transmitted by facsimile to the Patent
and Trademark Office.

DATED: February 23, 2005

Dear Sir:

This is in response to the Office Action dated December 28, 2004, for which the three-month shortened statutory period is set to expire on March 28, 2004. While Applicant believes that no extension of time for response is necessary, should the Office determine that any additional fees are necessary for this response, the Commissioner is hereby authorized to charge any deficiencies to Deposit Account No. 12-2252.

Appl. No.: 10/627,289
Reply to Office Action of December 28, 2004

Sir:

In response to the Office action of December 28, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.